

## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:		)	Examiner: Not Yet Assigned
HIROSHI WATANABE ET AL.		) :	Group Art Unit: Not Yet Assigned
Application No.: 10/619,576		)	
Filed: July 16, 2003		) :	
For:	SUBSTRATE PROCESSING METHOD AND SUBSTRATE PROCESSING APPARATUS	) :	September 17, 2003
P.O. B	issioner for Patents ox 1450		

## PRELIMINARY AMENDMENT

Sir:

## A. Introductory Comments

Prior to the examination on the merits, please amend the above-captioned application as follows and consider the following remarks.